

PRODUCTION OF  $S_2F_{10}$  BY  $SF_6$  SPARK DISCHARGES

I. Sauers, P. C. Votaw, and G. D. Griffin

Health and Safety Research Division  
Oak Ridge National Laboratory  
P. O. Box 2008  
Oak Ridge, Tennessee 37831-6123

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Introduction

Sulfur hexafluoride ( $SF_6$ ) is known to fragment in an electrical discharge, leading to the formation of various sulfur-fluorides (Frees and others, 1981; Sauers and others, 1986; Van Brunt, 1985). Of particular interest is the compound  $S_2F_{10}$  (sulfur decafluoride) which has been reported in spark discharges (Becher and Massonne, 1970; Bartakova, 1978), in corona (Bartakova, 1978), and in arc discharges (Pettinga, 1985). The potential presence of this by-product in electrical systems is significant due to its extremely high toxicity and its relatively low thermal stability. The TLV-TWA (threshold limit value-time weighted average) for human exposure to  $S_2F_{10}$  recommended by the American Conference of Governmental Industrial Hygienists is 25 parts per billion. At room temperature  $S_2F_{10}$  is extremely stable, having a calculated half-life of  $10^5$  years based on the unimolecular decomposition rate constant  $k$  (Trost and McIntosh, 1952; Benson and Bott, 1969; Herron, 1987) given by

$$k = 5.6 \times 10^{18} \exp(-45,700/RT) \quad (1)$$

where  $k$  is in  $s^{-1}$  and  $RT$  is in calories. However at elevated temperatures,  $S_2F_{10}$  will decompose as indicated by the gas chromatograms shown in Fig. 1 (Sauers and others, 1988). Above  $\sim 200^\circ C$   $S_2F_{10}$  is considered to be thermally unstable. This decomposition temperature is relatively low compared to other sulfur-fluorides, and its formation in discharges where high temperatures exist has been controversial. In this paper, we report on the influence of moisture on  $S_2F_{10}$  formation and the product yield under our experimental conditions.

Experiment

Sparked  $SF_6$  was prepared by repeatedly discharging a 0.1  $\mu F$  capacitor into a stainless-steel (SS) chamber housing SS electrodes with concentric cylindrical geometry. The energy discharged in one spark was typically 15 J, and the total energy discharged into the gas fell in the range 4-32 kJ. The gas was analyzed primarily for  $S_2F_{10}$  using a Perkin-Elmer Sigma 3 gas chromatograph (GC) with a thermal conductivity detector. The column used for separating  $S_2F_{10}$  from  $SF_6$  was 30% SP-2100 on chromosorb WAW packed in 24' x 1/8" teflon tubing obtained from Supelco. Table 1 lists the retention times for various compounds expected to be found in sparked  $SF_6$ .

Results and Discussion

Effect of moisture. Generally  $S_2F_{10}$  was observed under dry conditions. Moisture was removed from the spark cell by treating the inside surfaces with  $SF_6$  (sulfur tetrafluoride).  $SF_6$  is known to react with water, having a gas phase rate constant for hydrolysis of  $k = 1.5 \pm 1 \times 10^{-19} \text{ cm}^3 \text{ s}^{-1}$  (Sauers and others, 1985) for the reaction

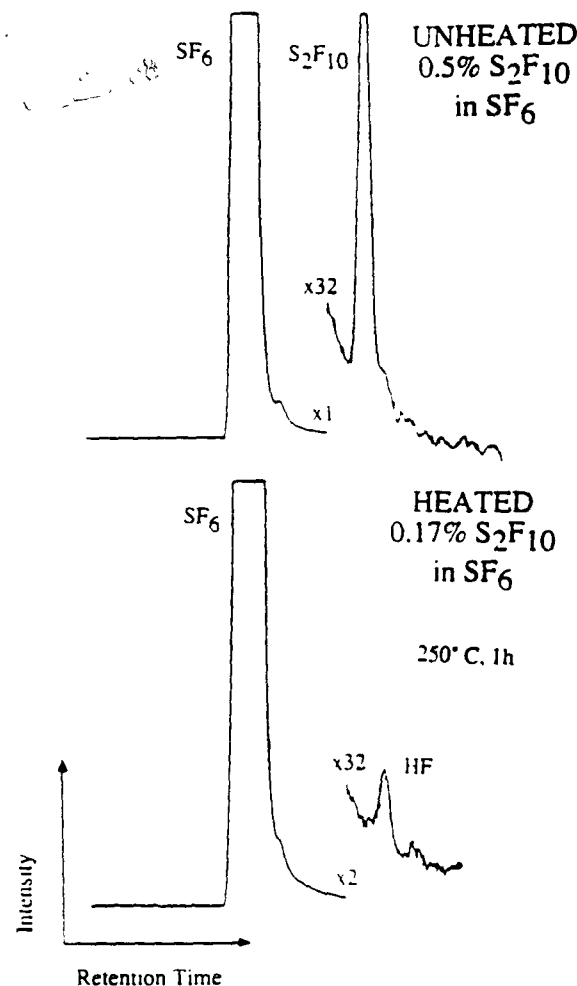
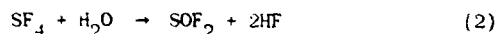


Fig. 1. Gas chromatograms of unheated (upper trace) and heated (lower trace)  $S_2F_{10}/SF_6$  mixtures. The heating parameters were  $250^\circ C$  for 1 h, corresponding to over 2000 half-lives for  $S_2F_{10}$  decomposition. Note the relative sensitivities as indicated by the multiplication factors given in this figure and in Fig. 2.

The spark cell was filled with  $SF_6$  to  $P = 0.5$  atm for 0.5 h. The gas was pumped out, and the process was repeated, followed by overnight pumping. The cell was then filled with  $SF_6$  to  $P = 133$  kPa and sparked. The GC analysis is illustrated in the upper trace of Fig. 2. After calibrating the analyzer with pure  $S_2F_{10}$ , the peak area was found to correspond to 160 ppm  $S_2F_{10}$  in  $SF_6$ .

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TABLE 1 Retention times (relative to  $N_2$ ) of various compounds injected in a 24' x 1/8" teflon column containing 30% SP-2100 on chromosorb WAW. The oven temperature and He flow were 50°C and 30 ml/min, respectively.

Compound	Retention Time (min)
$SF_6$	0.194
$SO_2F_2$	0.481
$SOF_4$	0.503
$SOF_2$ ; $SF_4$	0.735
$SO_2$	1.8-2.5 <sup>†</sup>
$S_2F_{10}$	2.154
HF	2.487
$SiF_4$	2.7-4.7 <sup>†</sup>

<sup>†</sup>The retention time for this compound was found to be concentration dependent. At low concentrations (i.e., where peak heights were comparable to that of  $S_2F_{10}$ ) the range for  $SO_2$  was 2.2 to 2.5 min. The  $SO_2$  peak was clearly distinguishable from  $S_2F_{10}$  by its retention time and peak shape.

Moisture was then added to "pure"  $SF_6$  in the amount of ~600 ppm, and the sparking experiment was repeated. The striking absence of  $S_2F_{10}$  is illustrated in the lower trace of Fig. 2. Although the moisture level in the dried cell is not known, the effect of drying and, hence, the effect of moisture on  $S_2F_{10}$  production is very apparent. On the other hand,  $S_2F_{10}$ , once formed, does not react with water at room temperature (Bailar, 1973). We have found that  $S_2F_{10}$  may be stored in an ordinary SS cylinder with no loss of  $S_2F_{10}$  over several weeks.

In a recent computational model study of  $S_2F_{10}$  formation in decomposed  $SF_6$ , Herron (1987) and Herron and Tsang (1987) address specifically the influence of water on  $S_2F_{10}$  formation. Two cases were considered: in the first case, it was assumed that  $SF_6$  decomposes at a slow rate to  $SF_4 + 2F$ ; while in the second case, it was assumed that  $SF_6$  fragments to  $SF_5 + F$ . In either case Herron (1987) argues that water reacts with fluorine by the process



to form OH radicals which, subsequently, react with  $SF_5$  in the reaction



This reaction competes with the recombination process



which occurs more efficiently in the absence of water. Because our spark discharges are expected to fragment  $H_2O$  as well as  $SF_6$ , OH radicals may be formed even without reaction (3), but the effect of OH on  $S_2F_{10}$  suppression might well be the same. Our present results on the effect of moisture qualitatively support this model.

The effect of moisture on  $S_2F_{10}$  formation raises important implications on the controlling factors for  $S_2F_{10}$  production. The view that is widely held is that  $S_2F_{10}$  is not expected to be formed in "hot" discharges such as arc discharges as opposed to "cold" discharges such as corona due to the thermal insta-

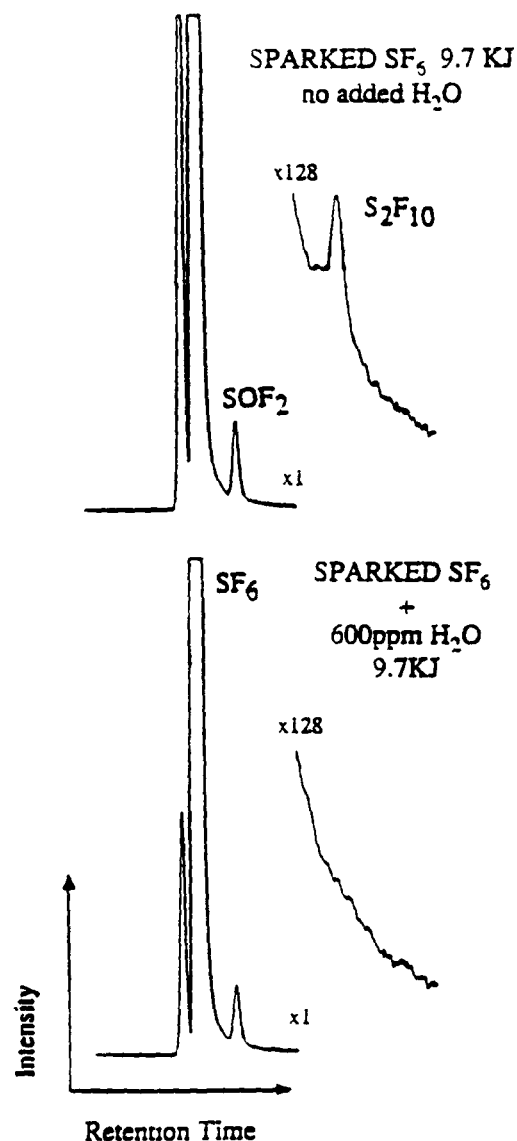


Fig. 2. Gas chromatograms of sparked  $SF_6$  at 9.7 kJ, showing the effects of added moisture.  $SF_6$  alone (upper trace),  $SF_6 + 600$  ppm  $H_2O$  (lower trace).

bility of  $S_2F_{10}$  above 200°C. Spark discharges may be considered an intermediate case. However, in a types of localized discharges, there are regions the outer edges that could be cool enough to form stable  $S_2F_{10}$ . The moisture level, however, may be more important factor in  $S_2F_{10}$  suppression than arc temperature itself.

**$S_2F_{10}$  Yield.** The  $S_2F_{10}$  peak in Fig. 2 corresponds a spark yield of  $6.8 \times 10^{-11}$  mol/J. This value may be compared to the spark yield of  $S_2F_{10}$  reported by Becher and Massonne (1970). Their results showed that after 30 min of sparking, corresponding to 54-90 total energy dissipation, the concentration of  $S_2F_{10}$  (plus  $S_2F_{10}O$ ) in the range of 40-140 ppm were produced. It is not entirely clear which of the two cells, described in their paper, was used for the  $S_2F_{10}$  measurements; however, if we assume that the 2 cell was employed, then the  $S_2F_{10} + S_2F_{10}O$  yields fall in the range  $0.05-0.17 \times 10^{-9}$  mol/J. Our results are consistent with those values, indicating that the Becher and Massonne experiments were conducted under similarly dry conditions.

## Conclusions

The highly toxic compound  $S_2F_{10}$  is formed in  $SF_6$  following spark discharges. When the spark cell is dried, the  $S_2F_{10}$  yield was  $6.8 \times 10^{-11}$  mol/J at an  $SF_6$  pressure  $P = 133$  kPa. Moisture appears to suppress the  $S_2F_{10}$  yield, although once formed, the  $S_2F_{10}$  is quite stable with respect to moisture. This could explain the variation in observation from experiment to experiment in the literature. These results also raise important questions as to the influence of drying agents that are used in high-voltage systems on the  $S_2F_{10}$  yield.

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